



IFW
PATENT
8007-1093

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Kiyohito HIROMITSU et al.

Conf. 2651

Application No. 10/537,358

Group 1722

Filed June 3, 2005

MOLD CLEANING MATERIAL AND MOLD CLEANING
METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 5, 2006

Sir:

Applicants submit herewith Form 1449 making of record a Chinese Official Action and English translation that provides a concise explanation of the relevance of JP 2001-79857 and JP 7-304044 which were previously cited in the Information Disclosure Statement of June 3, 2005.

Respectfully submitted,

YOUNG & THOMPSON

Benoit Castel

Benoit Castel, Reg. No. 35,041
745 South 23rd Street
Arlington, VA 22202
Telephone (703) 521-2297
Telefax (703) 685-0573
(703) 979-4709

BC/lk

(Use several sheets if necessary)

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10/537,358

Applicant:

Kiyohito HIROMITSU et al.

Filing Date:

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Group Art Unit:

1722

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/G.W./		English translation of July 7, 2006 Chinese Official Action in corresponding Chinese Application No. 200380104791.2

EXAMINER:

/Gregory Webb/

DATE CONSIDERED

03/16/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

* Abstract provided for the Examiner's convenience